



Solid State Devices, Inc.

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DESIGNER'S DATA SHEET

Part Number / Ordering Information ^{1/}

SFF9140 -28



Screening ^{2/}

— = Not Screened

TX = TX Level

TXV = TXV Level

S = S Level

Package

-28 = LCC28

SFF9140-28

-18 AMP
-100 Volts
0.20 Ω
P-Channel
POWER MOSFET

Features:

- Rugged Construction with Poly Silicon Gate
- Low $R_{DS(ON)}$ and High Transconductance
- Excellent High Temperature Stability
- Very Fast Switching Speed
- Fast Recovery and Superior dv/dt Performance
- Increased Reverse Energy Capability
- Low Input and Transfer Capacitance for Easy Paralleling
- Hermetically Sealed
- TX, TXV, and Space Level Screening Available. Consult Factory.
- Replaces IRF9140 Types

Maximum Ratings ^{3/}	Symbol	Value	Unit
Drain – Source Voltage	V_{DS}	-100	V
Gate – Source Voltage	V_{GS}	±20	V
Continuous Drain Current	I_D	$T_C = 25^\circ C$	18
		$T_C = 100^\circ C$	11
Operating & Storage Temperature	$T_{OP} \& T_{STG}$	-55 to +150	°C
Thermal Resistance, Junction to Case	$R_{\theta JC}$	3.5	°C/W
Total Device Power Dissipation	P_D	$T_C = 25^\circ C$	36
		$T_C = -55^\circ C$	27
Single Pulse Avalanche Energy	E_{AS}	500	mJ
Repetitive Avalanche Energy	E_{AR}	12.5	mJ

NOTES:

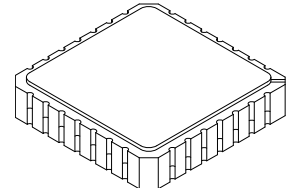
*Pulse Test: Pulse Width = 300 μsec, Duty Cycle = 2%.

^{1/} For ordering information, price, and availability - contact factory.

^{2/} Screening based on MIL-PRF-19500. Screening flows available on request.

^{3/} Unless otherwise specified, all electrical characteristics @25°C.

LCC28



NOTE: All specifications are subject to change without notification. SCD's for these devices should be reviewed by SSDI prior to release.

DATA SHEET #: FP0011C

DOC



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Electrical Characteristics ^{3/}		Symbol	Min	Typ	Max	Unit	
Drain to Source Breakdown Voltage ($V_{GS} = 0\text{ V}$, $I_D = 1\text{ mA}$)		BV_{DSS}	-100	—	—	V	
Drain to Source On State Resistance ($V_{GS} = -10\text{ V}$)		$R_{DS(ON)}$	—	0.15	0.20	Ω	
				—	0.23		
Temperature Coefficient of Breakdown Voltage		$\frac{\Delta BV_{DSS}}{\Delta T_J}$	—	-0.087	—	A	
Gate Threshold Voltage ($V_{DS} = V_{GS}$, $I_D = -250\ \mu\text{A}$)		$V_{GS(th)}$	-2.0	—	-4.0	V	
Forward Transconductance ($V_{DS} \geq 15\text{ V}$, $I_{DS} = 11\text{ A}$)		g_{fs}	6.2	8	—	S(Ω)	
Zero Gate Voltage Drain Current ($V_{DS} = 80\%$ rated voltage, $V_{GS} = 0\text{ V}$) ($V_{DS} = 80\%$ rated voltage, $V_{GS} = 0\text{ V}$)		I_{DSS}	—	—	25	μA	
				—	250		
Gate to Source Leakage Forward Gate to Source Leakage Reverse		At Rated V_{GS} I_{GSS}	—	—	-100	nA	
			—	—	100		
Total Gate Charge Gate to Source Charge Gate to Drain Charge		$V_{GS} = -10\text{ V}$ 50% rated V_{DS} $I_D = 18\text{ A}$	Q_g Q_{gs} Q_{gd}	31 — 7	50 3 25	70 18 45	nC
Turn on Delay Time Rise Time Turn off Delay Time Fall Time		$V_{DD} = 50\%$ rated V_{DS} rated I_D $R_G = 9.1\ \Omega$	$t_{d(on)}$ t_r $t_{d(off)}$ t_f	— — — —	15 8 35 20	35 85 85 65	ns
Diode Forward Voltage ($I_S = \text{Rated } I_D$, $V_{GS} = 0\text{ V}$, $T_J = 25^\circ\text{C}$)		V_{SD}	—	—	-4.2	V	
Diode Reverse Recovery Time Reverse Recovery Charge		$T_J = 25^\circ\text{C}$ $I_F = 10\text{ A}$ $di/dt = 100\text{ A}/\mu\text{sec}$	t_{rr} Q_{RR}	— —	170 —	280 3.6	ns μC
Input Capacitance Output Capacitance Reverse Transfer Capacitance		$V_{GS} = 0\text{ V}$ $V_{DS} = -25\text{ V}$ $f = 1\text{ MHz}$	C_{iss} C_{oss} C_{rss}	— — —	1400 600 200	— — —	pF

